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Patent

Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Weimer, Ronald A.
Serial No. : 09/941,827
Filing Date : August 29, 2001
For : Method of Improved High K Dielectric-Polysilicon Interface
Confirmation No. : 7551
Examiner : Yennhu B Huynh
Group Art Unit : 2813

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

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37 CFR 1.8(a)

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37 CFR 1.10

Transmission

Date: February 9, 2004

Jill H. Strodt

Commissioner for Patents
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STATUS INQUIRY

Dear Sir:

This application was filed on August 29, 2001, and the last correspondence filed in this application is a Response After Non-Final action dated September 4, 2003.

More than **twenty-nine (29)** months (from the filing date) and **five (5)** months (from the date of the Response After Non-Final action) have passed without receiving any communication from the U.S. Patent and Trademark Office. Please provide us with a status of this application.

Respectfully submitted,

Dated: February 6, 2004

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